



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

In Re PATENT APPLICATION Of:

Applicant: Mikio OHTAKI

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Appln. No.: 09/904,663

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AMENDMENT

Filed: July 16, 2001

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For: METHOD FOR MANUFACTURING  
AND BATCH TESTING  
SEMICONDUCTOR DEVICES

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Atty Ref.: KAN 120D1

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September 4, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Mail Stop – Non-Final Office Action**

Sir:

Responsive to the Examiner's Action dated May 7, 2003, a Petition for a One-Month Extension of Time being submitted herewith, please amend the application as shown on the following pages.

FEE ENCLOSED:\$110  
Please charge any further  
fees to our Deposit Account  
No. 18-0002